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AUG 26 2005

**METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER
CRYSTALLIZATION PROCESS**

Appl. No. : 10/604,687 Confirmation No. 1686
Applicant : Kun-chih Lin
Filed : August 11, 2003
TC/A.U. : 2822
Examiner : Guerrero, Maria F
Docket No. : ADTP0067USA0
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Sir:

- 5 In response to the Office action of 06/14/2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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